

#### **CALIBRATION LABORATORIES**

#### **NVLAP LAB CODE 200605-0**

#### SCOPE OF ACCREDITATION TO ISO/IEC 17025:2017

Mahr Inc.

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Phone: 401-784-3214 Fax: 401-784-3238 E-mail: anthony.clang@mahr.com URL: http://www.mahr.com Fields of Calibration

Dimensional

This laboratory is compliant to ANSI/NCSL Z540-1-1994; Part 1. (20/A01)

CALIBRATION AND MEASUREMENT CAPABILITIES (CMC) Notes 1,2				
Measured Parameter or		Expanded		
Device Calibrated	Range	Uncertainty Note 3	Remarks	
	DIME	NSIONAL		
ANGULAR (20/D01)				
Electronic Level System	≤ 1000"	0.40"	Sine Plate with Gage Blocks	
Angle Measure				
Protractors and Digital Angle				
Gage	≤90°	75"	Angle Blocks	
GAGE BLOCKS (20/D03)				
Steel & Ceramic	0.05 in	2.5 μin	Gage Blocks and 130B	
(See Note 8 for other materials)	0.100 in to 0.19 in	2.5 μin	Comparator	
	0.200 in to 0.950 in	2.5 μin	_	
	1 in to 2 in	3.0 µin		
	3 in	3.5 µin		
	4 in	4.5 μin		
	1 mm	62 nm		
	2.5 mm to 4.5 mm	63 nm		
	5 mm to 24.5 mm	65 nm		
	25 mm to 50 mm	73 nm		
	75 mm	88 nm		
	100 mm	0.11 μm		
Long Gage Blocks	5 in to 20 in	5.0 μin + 1.3μin/in	Gage Blocks and 130B	
	125 mm to 500 mm	$0.13 \ \mu m + 0.0013 \ \mu m/mm$	Comparator	

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CALIBRATION AND MEASUREMENT CAPABILITIES (CMC) Notes 1,2			
Measured Parameter or		Expanded	
Device Calibrated	Range	Uncertainty Note 3	Remarks
LENGTH and DIAMETER;			
Dial and Digital Indicators	\( \le 0.500 \text{ in (6.35 mm)} \) > 0.500 \text{ in (6.35 mm)} \) to 4.00 \text{ in (101.6 mm)}	14 μin (0.4 μm) 31 μin (0.8 μm)	Indicator Calibrators
High Resolution Indicators	± 0.100 in (± 2.54 mm) ± 0.010 in (± 254 μm) ± 0.001 in (± 25.4 μm) ≤ 1.000 in (≤ 25.4 μm)	9 μin (0.22 μm) 7 μin (0.17 μm) 4 μin (0.10 μm)	Microcalibrator
Marshaft Machines (Diameter and Length) MarShaft Scope Manual w/MC Field calibrations	≤ 1.000 in (≤ 25.4 mm)  Length (< 2400 mm)  Diameter (< 120 mm)	5.6 μin (0.14 μm) 6 μm + 1.1L / 100 μm 2.2 μm + L / 100 μm	Laser Interferometer  (L=mm) Helios Shaft Standard
available Note 4,7  MarShaft Scope Manual w/UNI  Field calibrations available Note 4,7	Length (< 2400 mm) Diameter (< 220 mm)	9 μm + 1.2 <i>L</i> / 100 μm 2 μm + <i>L</i> / 100 μm	( <i>L</i> =mm) Helios Shaft Standard
MarShaft Scope / Helios Scope Field calibrations available Note 4,7	Length (1000 mm)  Diameter (< 80 mm)	5 μm + 1.2L / 100 μm 3 μm + L / 100 μm	( <i>L</i> =mm) Helios Shaft Standard
MarShaft Scope 250+ Field calibrations available Note 4,7	Length (< 250 mm) Diameter (< 40 mm)	4.3 $\mu$ m + $L$ / 100 $\mu$ m 2.5 $\mu$ m + $L$ / 40 $\mu$ m	( <i>L</i> =mm) Helios Shaft Standard
MarShaft Scope plus Field calibrations available Note 4,7	Length (< 1000 mm) Diameter (< 120 mm)	4 μm + 1.2L / 125 μm 3 μm + L / 125 μm	( <i>L</i> =mm) Helios Shaft Standard

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Measured Parameter or		Expanded	
<b>Device Calibrated</b>	Range	Uncertainty Note 3	Remarks
MarShaft CNC	Length (< 1600 mm)	4 μm + 1.1 <i>L</i> / 100 μm	(L=mm) Helios Shaft
Field calibrations available Note 4,7	Diameter (< 220 mm)	2 μm + L / 100 μm	Standard
Length – Air Amplifiers Field calibrations available Note 4,7	0.00015 in to 0.005 in	11 μin (0.27 μm)	AMR – Air Restrictor
Diameter – Air restrictor kits	$\leq 0.00030 \text{ in}$	9 μin	Gage Blocks, Dimensionair
Branice 7 in restrictor kits	> 0.00030  in > 0.00030 in to 0.003 in	18 μin	Guge Brocks, Bimensionan
	> 0.003 in to 0.005 in	27 μin	
		1	
Length and Diameter – Outside Micrometers 0.0001 in Resolution 0.001 in Resolution	< 6 in < 6 in	31 μin 300 μin	Gage Blocks
Universal Length Measuring			
Machines	< 4.0 in	3 μin + 0.4 μin/in	Gage Blocks
Field calibrations	> 4.0 in to 12.0 in	3.3 μin + 1.3 μin/in	
available Note 4,7	≤ 100 mm	0.076 μm + 0.0004 μm/mm	
	> 100 mm to 305 mm	$0.084 \ \mu m + 0.0013 \ \mu m/mm$	
	≤ 31 in (≤ 800 mm) ≤ 47.24 in (≤ 1200 mm) ≤ 78.8 in (≤ 2000 mm)	33 μin (0.84 μm) 45 μin (1.13 μm) 69 μin (1.75 μm)	Laser Interferometer
Length Amplifier Probe	< 0.020 in	3.5 µin	Gage Blocks
Systems	0.020 in to 0.160 in	13 µin	Gage Blocks
Systems	$\leq 0.10 \text{ in}$	5.6 μin	
	_ ****	a so pass	Laser
Heidenhain CT Probes	Up to 2.37" (60mm)	7 μin (0.18 μm)	Gage Blocks
		. ` ' /	
Heidenhain MT Series			
Probes	up to 1.00" (25.4mm)	10μ" (0.25μm)	Laser

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CALIBRATION AND MEASUREMENT CAPABILITIES (CMC) Notes 1,2				
Measured Parameter or		Expanded		
Device Calibrated	Range	Uncertainty Note 3	Remarks	
Universal Height Measuring				
Machines				
Field calibrations available Note 4,7				
CX1	< 1000 mm	$0.7 \mu m + (L/350) \mu m$	Step Gage	
CX2	< 1000 mm	$2.3 \mu m + (L/350) \mu m$		
817 CLM	< 1000 mm	$1 \mu m + (L/500) \mu m$		
816 CL	< 600 mm	$2 \mu m + (L/350) \mu m$		
814N & 814G	< 600 mm	$6 \mu m + (L/2000) \mu m$		
814SR	< 600 mm	$12 \mu m + (L/2000) \mu m$	(L=mm) in formulas	
Indicating Height Stands	≤ 4 in (≤ 101.6 mm)	74 μin (1.8 μm)	Gage Blocks	
Indicator (Universal) Calibrators Field calibrations available Note 4,7	≤ 0.5 in (≤ 12.7 mm)	9.0 μin (0.23 μm)	Gage Blocks	
Optimar100 Field calibrations available Note 4,7	≤ 4.0 in (≤ 101.6 mm)	14 μίη (0.36 μm)	Heidenhain Probe	
Optimar25	$\leq 1.0 \text{ in } (\leq 25.4 \text{ mm})$	6.0 μin (0.15 μm)	Laser	
Field calibrations	$\leq 1.0 \text{ in } (\leq 25.4 \text{ mm})$	20 μίπ (0.50 μm)	Amplifier Probe System	
available Note 4,7	$\leq 1.0 \text{ in } (\leq 25.4 \text{ mm})$	18 μίη (0.40 μm)	Gage Blocks	
Gage Block and ID/OD Comparators Field calibrations available Note 4,7	≤ 0.002 in ≤ 10 μin	3.2 μin (0.08 μm) 0.5 μin (0.013 μm)	Gage Blocks	

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CALIBRATION AND MEASUREMENT CAPABILITIES (CMC) Notes 1,2			
Measured Parameter or		Expanded	
Device Calibrated	Range	Uncertainty Note 3	Remarks
Dimentron plug and	< 1 in	13 μίη (0.33 μm)	Master Ring / Gage Blocks
Bore gages	$\geq 1$ in to 2 in	17 μin (0.43 μm)	
	> 2 in to 3 in	18 μin (0.46 μm)	
	> 3 in to 4 in	18 μin (0.46 μm)	
	> 4 in to $<$ 5 in	28 μin (0.71 μm)	
	> 0.125 in to 5 in	18 μin (0.46 μm)	Master Ring / T-50075
Thickness Gages	≤ 0.00005 in	33 μin (0.84 μm)	Gage Blocks
Portable	> 0.00005	65 μin (1.6 μm)	
	$to \le 0.0001$ in		
	$> 0.0001$ in to $\le 0.001$ in	720 μin (18 μm)	
Bench	≤ 1 in (≤ 25.4 mm)	31 μin (0.77 μm)	Gage Blocks
Digital, Dial & Vernier	Up to 8 in	300 μin (15 μm)	Gage Blocks / Master Ring
Calipers	> 8 in to 40 in	600 μin (30 μm)	
Inside Micrometers			
0.0001	> 0 in to 4 in	32 μin	Master rings
0.001		300 μin	
36 ID/OD Comparators			
	$\pm 0.010$ in ( $\pm .254$ mm)		Master Ring / Gage Blocks
≤0.0001 Res.		250 μin	
≤0.00005 Res.		66 µin	
MEASURING WIRES (20/		<u> </u>	l
Thread Measuring Wires	$\leq 0.55$ in	6.5 μin	ASME B89.1.17 using
Diameter			Master Thread Measuring
			Wires and Universal Length
DOLINDARGO (AS TOS)			machine
ROUNDNESS (20/D09)	100 :	Γ	D. 6771. 100 D. 60.100
Roundness	< 100 μin	1 μin	MFU 100, or MMQ400
Artifacts/ Standards	$\leq 0.004 \text{ in}$	3.5 μin (0.09 μm)	Form/Geometry Measuring
Diameters	> 0.004 in to 0.04 in	25 μin (0.64 μm)	Machines
0.124 in to 14.5 in			

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Measured Parameter or		Expanded	
Device Calibrated	Range	Uncertainty Note 3	Remarks
SPHERICAL DIAMETER	; PLUG / RING GAGES (	20/D11)	
Master Plugs, Pins, Wires, Master Balls and	> 4.000 in	7.5 µin	Gage Blocks & ULM300
Micrometer standards (OD and Length)	≥ 4.000 in > (4.000 to 12.000) in	8.0 μin 10 μin+ 1 μin/in	Gage Blocks & 828 CiM
	< 5.000 in > (5.000 to 36.000) in	6.0 μin 4.5+(0.25L) μin	Gage Blocks & PLM1000-E
	<pre> ≤ 1.000 in &gt; (1.000 to 2.000) in &gt; (2.000 to 4.5000) in </pre>	7.0 μin 7.5 μin 8.0 μin	Gage Blocks & 136B-3 Comparator
Master Ring Gages and inside diameters (ID and Length)	(0.030 to 5.000) in >5.000	8 μin 10 μin + 1 μin/in	Master rings and 828 CiM/ULM300
	≤ 5.000 in > (5.000 to 33.0) in	6.0 μin 4.5+(0.25L) μin	Master ring & PLM1000-E
	<pre> ≤ 1.000 in &gt; (1.000 to 2.000) in &gt; (2 to 4.500) in</pre>	7.0 μin 7.5 μin 8.0 μin	Gage Blocks & 136B-3 Comparator
Air Rings	≤ 4 in > 4 in to 14 in	17 μin 17 μin + 3.5 μin/in	Master Disc/Plug, Mahr Air Amplifier Calibrator, Electronic Amplifier
Air Plugs	≤ 4 in > 5 in to 10 in	17 μin 17 μin + 3.5 μin/in	Master Rings, Mahr Air Amplifier, Electronic Amplifier
Tapered Plug and Rings - Diameter	≤ 4 in	30 μin	Gage Blocks/ 136B-3 Comparator

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Device Calibrated	Range	Uncertainty Note 3	Remarks
SURFACE TEXTURE (20/D	012)		
Surface Roughness			
Ra (Roughness Average)	1 μin to 250 μin	1 μin	Mahr Surface and Contour
Rz	1 μin to 500 μin	2.5 µin	Measuring Machines
Flatness	Up to 14.5 in	4.5 μin	Optical Flat
Optical Flats	< 14.5 in (round) or	4.5 μin (0.11 μm)	Optical Flat
	< 13 in (rectangular)		
General Surface Variance			
Measurements	< 0.08 in	17i.	922 Amulifian Sina Dlata Pr
Flatness	< 0.08 in	17 μin	832 Amplifier, Sine Plate &
Parallelism	< 0.08 in	17 μin	Gage blocks, Granite surface
Runout (Total Runout)	< 0.08 in	17 μin	plate
Length / Height	Up to 24" (610mm)	17μin	832 Amplifier probe system with Gage blocks
Surface Contour			
Angle	≤ 90°	36"	LD-120, Contour 1 Master
Distance X	≤ 83 mm	$(D/100) + 1.5 \mu m$	(D = Distance in mm)
Distance Z	≤ 6.3 mm	$(D/100) + 1.5 \mu m$	
Radius	< 22.5 mm	0.12R μm	(R= Radius in mm)
Surface Finish & Contour			
Measuring Machines Field calibrations available Note 4,7			
Ra (Roughness Average)	1 μin to 250 μin	1.0 μin (0.025 μm)	Contour-2 ball master,
Rz	1 μin to 500 μin	2.5 μin	Displacement standard,
			Surface Finish Standard
			or Mahr Surface and Contour
			Measuring Machine
Wt	< 60 μin/in	6.0 μin (0.15 μm)	Optical Flat
Displacement	180 μin to 240 μin	3.0 μin (0.076 μm)	Step Height Standard

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Measured Parameter or		Expanded	
<b>Device Calibrated</b>	Range	Uncertainty Note 3	Remarks
Length	1 mm to 70 mm	16 μίη (0.41 μm)	Gage Blocks
Gage Pin Radius	2 mm to 4 mm	7.0 μin (0.18 μm)	Gage Pin
Sphere Radius	> 4 mm to 25 mm	20 μin (0.51 μm)	Precision Sphere (2 ball master)
TWO DIMENSIONAL GAG	SES (20/D15)	l	(2 out muster)
Concentricity Diameter: ≤ 14.5 in and Height: ≤ 13.75 in	<pre></pre>	5.0 μin (0.12 μm) 25 μin (0.64 μm)	MFU100 / MMQ400-2 Form and Geometry Measuring Machines
Cylindricity Height: ≤ 1.5 in and Diameter: ≤ 14.5 in	≤ 0.0001 in	2.0 μin (0.05 μm)	MFU100 / MMQ400-2 Form and Geometry Measuring Machines
Height: ≤ 4.0 in and Diameter: ≤ 14.5 in	≤ 0.004 in	6.0 μin (0.15 μm)	Measuring Machines
Height: > 4.0 in to 13.75 in and Diameter: ≤ 14.5 in	≤ 0.004 in	16 μίη (0.41 μm)	
Height: ≤ 4.0 in and Diameter: ≤ 14.5 in	> 0.004 in to 0.040 in	26 μin (0.66 μm)	
Height: > 4.0 in to 13.75 in and Diameter: ≤ 14.5 in	> 0.004 in to 0.040 in	30 μin (0.76 μm)	
Straightness (Z) (X)	14.5 in 4 in	0.03 + (L/1000) μm 0.05 + (L/1000) μm	L = Length in mm
Flatness Diameter: ≤ 14.5 in and Height: ≤ 13.75 in	<pre></pre>	3.5 μin (0.089 μm) 25 μin (0.64 μm)	MFU100 / MMQ400-2 Form and Geometry Measuring Machines

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Measured Parameter or		Expanded	
Device Calibrated	Range	Uncertainty Note 3	Remarks
Parallelism			MFU100 / MMQ400-2
Diameter: $\leq 14.5$ in and	$\leq$ 0.004 in	4.5 μin (0.11 μm)	Form and Geometry
Height: $\leq 13.75$ in	> 0.004 in to 0.040 in	34 μin (0.87 μm)	Measuring Machines
Perpendicularity			MFU100 / MMQ400-2
Diameter: $\leq 14.5$ in and	$\leq$ 0.004 in	4.0 μin (0.10 μm)	Form and Geometry
Height: $\leq 13.75$ in	> 0.004 in to 0.040 in	25 μin (0.64 μm)	Measuring Machines
Runout			
Diameter: $\leq 14.5$ in and	$\leq 0.004 \text{ in}$	5.0 μin (0.13 μm)	MFU100 / MMQ400-2
Height: $\leq 13.75$ in	> 0.004 in to 0.040 in	25 μin (0.64 μm)	Form and Geometry
C			Measuring Machines
Total Runout			
Diameter: $\leq 14.5$ in and	$\leq$ 0.004 in	6.0 μin (0.15 μm)	MFU100 / MMQ400-2
Height: $\leq 13.75$ in	> 0.004 in to 0.040 in	25 μin (0.64 μm)	Form and Geometry
-			Measuring Machines
Geometry / Form Measuring			
Machines			
Field calibrations available Note 4,7			
Radial Departure	< 50 μin	1.2 μin (0.030 μm)	Precision Sphere
Axial Deviation	< 50 μm	1.0 μin (0.025 μm)	Optical Flat
Probe Calibration	< 0.040 in	40 μin (1.0 μm)	Gage Blocks
Z Axis Straightness	$< 2 \mu m / 100 mm$	3.0 μin (0.08 μm)	Cylindrical Square
Z Axis Straightness Z Axis Parallelism	$< 10 \mu \text{m} / \text{m}$	16 μin (0.41 μm)	Cylindrical Square  Cylindrical Square
X Axis Perpendicular	$< 10 \mu \text{m} / \text{m}$ $< 10 \mu \text{m} / \text{m}$	12 μin (0.30 μm)	Optical flat
X Axis Ferpendicular X Axis Straightness	< 7.0  in  / 180  mm	8 μin (0.20 μm)	Optical flat
111mb Sharanings	, 100 mm	(0.20 mii)	opiioni iim
END			

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#### Notes

Note 1: A Calibration and Measurement Capability (CMC) is a description of the best result of a calibration or measurement (result with the smallest uncertainty of measurement) that is available to the laboratory's customers under normal conditions, when performing more or less routine calibrations of nearly ideal measurement standards or instruments. The CMC is described in the laboratory's scope of accreditation by: the measurement parameter/device being calibrated, the measurement range, the uncertainty associated with that range (see note 3), and remarks on additional parameters, if applicable.

Note 2: Calibration and Measurement Capabilities are traceable to the national measurement standards of the U.S. or to the national measurement standards of other countries and are thus traceable to the internationally accepted representation of the appropriate SI (Système International) unit.

Note 3: The uncertainty associated with a measurement in a CMC is an expanded uncertainty with a level of confidence of approximately 95 %, typically using a coverage factor of k = 2. However, laboratories may report a coverage factor different than k=2 to achieve the 95 % level of confidence. Units for the measurand and its uncertainty are to match. Exceptions to this occur when marketplace practice employs mixed units, such as when the artifact to be measured is labeled in non-SI units and the uncertainty is given in SI units (Example: 5 lb weight with uncertainty given in mg).

Note 3a: The uncertainty of a specific calibration by the laboratory may be greater than the uncertainty in the CMC due to the condition and behavior of the customer's device and specific circumstances of the calibration. The uncertainties quoted do not include possible effects on the calibrated device of transportation, long term stability, or intended use.

Note 3b: As the CMC represents the best measurement results achievable under normal conditions, the accredited calibration laboratory shall not report smaller uncertainty of measurement than that given in a CMC for calibrations or measurements covered by that CMC.

Note 3c: As described in Note 1, CMCs cover calibrations and measurements that are available to the laboratory's customers under normal conditions. However, the laboratory may have the capability to offer special tests, employing special conditions, which yield calibration or measurement results with lower uncertainties. Such special tests are not covered by the CMCs and are outside the laboratory's scope of accreditation. In this case, NVLAP requirements for the labeling, on calibration reports, of results outside the laboratory's scope of accreditation apply. These requirements are set out in Annex A.5 of NIST Handbook 150, Procedures and General Requirements.

Note 4: Uncertainties associated with field service calibration may be greater as they incorporate on-site environmental contributions, transportation effects, or other factors that affect the measurements. (This note applies only if marked in the body of the scope.)

Note 5: Values listed with percent (%) are percent of reading or generated value unless otherwise noted.

Note 6: NVLAP accreditation is the formal recognition of specific calibration capabilities. Neither NVLAP nor NIST guarantee the accuracy of individual calibrations made by accredited laboratories.

Note 7: This laboratory has field service technicians located across the U.S., Mexico, Brazil and South America. Field calibrations may be provided by these technicians at the customer facility.

Note 8: Uncertainties listed are for steel blocks. Add 1.5 µin / 38.1 nm for chrome carbide, 2.3 µin / 58.4 nm for tungsten carbide to the uncertainty listed.

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